

Application/Control No.	Applicant(s)/Patent under Reexamination	_
09/901,804	SMIALEK, MICHAEL ROBERT	_
Examiner	Art Unit	
Uyen T. Le	2163	

	SEAR	CHED	
Class	Subclass	Date	Examiner
707	1,100	Jan 06	bl.
4	102		
717	104		
	105		
	108		
	109		
	162		
	165	$\overline{V}$	$\bigvee$
	-		
		*	
	=		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
applated EAST ACM PRO QUEST	9 jan 06	til_		
Comited class/sorbo 707 \$ 717 dext feareh				